IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of	Confirmation No.: 5571
Masanobu SATO et al.	Date: March 8, 2007
Serial No.: 10/767,756	Group Art Unit: 2813
Filed: January 28, 2004	Examiner: Unassigned

For: SUBSTRATE TREATMENT METHOD AND SUBSTRATE TREATMENT APPARATUS

VIA EFS-WEB
Commissioner for Patents
P.O. Box 1450
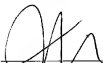Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

THIS CORRESPONDENCE IS BEING SUBMITTED ELECTRONICALLY THROUGH THE PATENT AND TRADEMARK OFFICE EFS FILING SYSTEM ON March 8, 2007.

Respectfully submitted,

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	Application 10/767,756		OFGS File No. P/2699-32		
APPLICANT'S ART CITATION (Use several sheets if necessary)	Applicant Masanobu SATO et al.				
	Filing Date January 28, 2004		Group Art Unit 2813		

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
	US-					
	US-					
	US-					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation Yes	No
	1999-013348	02-1999	Korea			English language translation of corresponding Japanese Patent Publication No. 11-031673	
	2000-254554	09-2000	Japan			X	
	2002-224592	08-2002	Japan			X	
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	2001-137747	05-2001	Japan			X	
	4-322731	11-1992	Japan			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Written Opposition issued December 12, 2006 in connection with the Korean Patent Application No. 10-2004-0011748 (Patent No. 602894)

Examiner	Date Considered

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered Include copy of this form with next communication to the applicant.

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